

## RECEIVED **CENTRAL FAX CENTER** MAY 1 8 2005

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# FACSIMILE COVER SHEET

Date:	May 18, 2005	Fax:	703-872-9306
То:	U.S. Patent and Trademark Office	Phone:	

**Commissioner for Patents** 

P. O. Box 1450

Alexandria, VA 22313-1450

From:	Brian D. Ogonowsky
Serial No.:	09/994,279
Docketi	PA1688 US (ANG-PA1688 US)
Re:	Response to Office Action
Pages:	12 (including cover sheet)

#### Message:

Re:

Applicant(s):

Chiang, Tony P.; Leeser, Karl F.

Assignee:

Novellus Systems, Inc.

Title:

Method for Integrated In-Situ Cleaning and Subsequent

Atomic Layer Deposition Within a Single Processing

Chamber

Serial No.:

09/994,279

Examiner:

David Nhu

Docket No.:

**PA1688 US** 

Filed: November 26, 2001

Group Art Unit: 2818

#### Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Transmittal Letter (1 page);
- (2) Credit Card Payment Form PTO-2038 (1 page);
- (3) Response to Office Action (7 pages);
- (4) Terminal Disclaimer (2 pages).

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Brian D. Ogonowsky

Carmen C. Cook

David C. Hsia

Rachel V. Leiterman

May 18, 2005

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

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 $\boxtimes$ The fee has been calculated as shown below:

		Claims Remaining	-	Highest No. Previously Paid For		Present Extra		Rate		Additional Fee	
Total	Claims	19	Minus	22	-	0	x	\$50	\$	0.00	
Indep Clain	endent ns	3	Minus	3	=	0	x	\$200	\$	0.00	
	Fee of for the first filing of one or more multiple \$ dependent claims per application										
$\boxtimes$	Termi	nal Disclaimer Fe	2						\$	130.00	
	Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.										
$\boxtimes$	Please charge our credit card (Form PTO-2038 enclosed) in the amount of Total \$									130.00	
$\boxtimes$	Also, c Accour	harge any addition: 1t No. 502226.	al fees require	ed and credit an	y ove	zpayment	to o	ur Depos	it		

Certificate of Facsimile Transmission

I hereby certify that this paper is being facefulle transmitted to the U.S. Patent and Trademark Office on the date shown below.

Respectfully submitted,

Brian D. Ogonowsky Attorncy for Applicant(s) Reg. No. 31,988

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Chiang, Tony P.; Leeser, Karl F.

Assignee:

Novellus Systems, Inc. (reassigned)

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San Jose, California May 18, 2005

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## RESPONSE TO OFFICE ACTION

Dear Sir:

This responds to the Office Action dated February 4, 2005, in the above-identified application. A terminal disclaimer is enclosed. Please amend the application to place all claims in condition for allowance as follows.

Amendments to the claims begin on page 2.

Remarks begin on page 7.

Patent Law Group LLP 2635 North First St. Suite 223 San Jose, CA 95134 (408) 382-0480 FAX (408) 382-0481

Scr. No. 09/994,279